



PATENT Attorney Docket No. 403018

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KAMIYAMA et al.

Group Art Unit: 2814

Application No. 10/811,979

Examiner: L. Pham

Filed: March 30, 2004

For:

METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE AND METHOD FOR FORMING HIGH-DIELECTRIC-CONSTANT FILM

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Pursuant to 37 CFR 1.97 and 1.98, the references listed on the enclosed Form PTO-1449 and/or Substitute Form PTO-1449 ("Form 1449") are submitted for consideration by the Examiner in the examination of the above-identified patent application.

The full consideration of the references in their entirety by the Examiner is respectfully requested and encouraged. Also, it is respectfully requested that the references be entered into the record of the present application and that the Examiner place his or her initials in the appropriate area on the enclosed Form 1449, thereby indicating the Examiner's consideration of each of the references.

The submission of the references listed on the Form 1449 is for the purpose of providing a complete record and is not a concession that the references listed thereon are prior art to the invention claimed in the patent application. The right is expressly reserved to establish an invention date earlier than the above-identified filing date in order to remove any reference submitted herewith as prior art should it be deemed appropriate to do so.

Further, the submission of the references is not to be taken as a concession that any reference represents art that is relevant or analogous to the claimed invention. Accordingly, the right to argue that any reference is not properly within the scope of prior art relevant to an examination of the claims in the above-identified application is also expressly reserved.

In re Appln. of KAMIYAMA et al. Application No. 10/811,979

The In	tormatic	on Disclosure Statement is being filed:				
	within any one of the following time periods: (a) within three months of the filing date of a national application other than a continued prosecution application under 37 CFR 1.53(d); (b) within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 of an international application; (c) before the mailing date of a first Office Action on the merits; or (d) before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.					
	after (a), (b), (c) or (d) above, but before the mailing date of a final action un 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an action otherwise closes prosecution in the application, and includes <i>one</i> of:					
		the Statement under 37 CFR 1.97(e) (see "Statement under 37 CFR 1.97(e)" below).				
	$\Box$	the fee of \$180 set forth in 37 CFR 1.17(p) (see "Fees" below).				
$\boxtimes$	after the mailing date of a final action under 37 CFR 1.113 or a Notice of Allowand under 37 CFR 1.311, or an action that otherwise closes prosecution in the application and on or before payment of the issue fee, and includes the Statement under 37 CFR 1.97(e) (see "Statement under 37 CFR 1.97(e)" below), and the fee of \$180 a set forth in 37 CFR 1.17(p) (see "Fees" below).					
	after the mailing date of a Notice of Allowance under 37 CFR 1.311, and on or before payment of the issue fee, and within thirty days of receiving each item of information contained in the Information Disclosure Statement, and includes the Statement under 37 CFR 1.704(d) (see "Statement under 37 CFR 1.704(d)" below), and the fee of \$180 as set forth in 37 CFR 1.17(p) (see "Fees" below).  NOTE: This is for original applications except applications for a design patent, filed on or after May 29, 2000, wherein a paper containing only an Information Disclosure Statement in compliance with 37 CFR 1.97 and 1.98 is being filed.					
Copie	s of the	References				
$\boxtimes$	Copies	of the references listed on the enclosed Form 1449 are enclosed herewith.				
	Copies of U.S. patents and patent applications that are listed on the accompanying Form 1449 are not enclosed herewith. Copies of other references identified on the accompanying Form 1449 are enclosed herewith.					
	relevar an Eng action degree	ed to each reference not in the English language is a concise explanation of the nce pursuant to 37 CFR 1.98(a)(3). An English-language equivalent/patent, or glish-language abstract, or an English-language version of the search report or by a foreign patent office in a counterpart foreign application indicating the of relevance found by the foreign office is being submitted in lieu of a concise ation of the relevance pursuant to 37 CFR 1.98(a)(3).				

In re A	Appln. of KAMIYAN cation No. 10/811,979	MA et al. 9					
	A copy of the foreign search report is enclosed herewith.						
	The references listed on the enclosed Form 1449 were previously identified in the parent application(s) of the present application, and copies of the references were furnished at that time. Accordingly, additional copies of the references are not submitted herewith, so as not to burden the file with duplicate copies of references. The Examiner is respectfully requested to carefully review the references in accordance with the requirements set out in the Manual of Patent Examining Procedure. In accordance with 37 CFR 1.98(d), the details of the parent application(s) relied upon for an earlier filing date under 35 USC 120 in which copies of the references were previously furnished are set out below:						
	U.S. APPLIC		S1	atus (check o	ne)		
	.S. APPLICATIONS	U.S. FILING DATE	PATENTED	PENDING	ABANDONED		
1.							
2.							
3.							
State	ment under 37 CFR						
	The undersigned hereby states that each item of information contained in the Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign patent application not more than three months prior to the filing of the Information Disclosure Statement.						
	The <b>undersigned</b> hereby states that no item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign patent application, and, to the knowledge of the undersigned after making reasonable inquiry, no item of information contained in the Information Disclosure Statement was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of the Information Disclosure Statement.						
State	ment under 37 CFR	1.704(d)					
	The <b>undersigned</b> hereby states that each item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart application and that this communication was not received by any individual designated in 37 CFR 1.56(c) more than thirty days prior to the filing of the Information Disclosure Statement.						
Fees	and Method of Payr	nent of Fees					
		the applicant(s). .ccount No. 12-1216 in ate copy of this commun					

In re Appln. of KAMIYAMA et al. Application No. 10/811,979

## **Authorization to Charge Additional Fees**

If any additional fees are owed in connection with this communication, please charge Deposit Account No. 12-1216. (A duplicate copy of this communication is enclosed for that purpose.)

## Instructions as to Overpayment

Credit Account No. 12-1216.

Respectfully submitted,

effre A. Wyand, Reg (No 29,458

LEYDIG, VOIT & MAVER
700 Thirteenth Street, N.W., Suite 300

Washington, DC 20005-3960 (202) 737-6770 (telephone) (202) 737-6776 (facsimile)

Date: JAW:ves

Please type a plus	s sign (+) inside this box	→[-	-	R B		
			18	Complete if Known		
Substitute for form 1449A/B/PTO		Application Number	10/811,979			
INFORMATION DISCLOSURE STATEMENT BY APPLICANT  (Use as many sheets as necessary)				Filing Date	March 30, 2004	
				First Named Inventor	KAMIYAMA	
				Group Art Unit	2814	
				Examiner Name	L. Pham	
Sheet	1	of	2	Attorney Docket Number	403018	

OTHER - NON PATENT LITERATURE DOCUMENTS								
Examiner Initials	Doc. No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item  Doc. No. (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number (s),			Translation Yes No*+			
IIIIIais		publisher, city and/or co			165	No		
	D 1	HOBBS, C. et al.; "Fermi Level Pinning at the Symposium of VLSI Tech. Digest of Technic	ne PolySI/M cal Paners	etal Oxide Interface", 2003				
		Symposium of VESI Tech. Digest of Technic	carr apers,	рр. о-т.				
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Examiner			Date Considered					

<sup>\*</sup> A concise statement of relevance is being submitted in lieu of a translation. 37 CFR 1.98(a)(3).